

Electronic Patent Application Fee Transmittal

Application Number:	10591343			
Filing Date:	31-Aug-2006			
Title of Invention:	Method for Manufacturing Semiconductor Device and Plasma Oxidation Method			
First Named Inventor/Applicant Name:	Masaru Sasaki			
Filer:	Marvin Jay Spivak/April Foubare			
Attorney Docket Number:	295715US26PCT			
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U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	130	130

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				130